

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): KESSLER, Berthold et al.

Application No.:

Group:

Filed: April 25, 2002

Examiner:

For: METHOD AND SENSOR DEVICE FOR MONITORING A LASER MACHINING  
OPERATION TO BE PERFORMED ON A WORK PIECE AS WELL AS LASER  
MACHINING HEAD WITH A SENSOR DEVICE OF THIS KIND

L E T T E R

Assistant Commissioner for Patents  
Box Patent Application  
Washington, D.C. 20231

April 24, 2001  
1739-0172P-SP  
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Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the  
applicant hereby claims the right of priority based on the following  
application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
Germany	101 20 251.2	04/25/01

A certified copy of the above-noted application(s) is(are)  
attached hereto.

If necessary, the Commissioner is hereby authorized in this,  
concurrent, and future replies, to charge payment or credit any  
overpayment to deposit Account No. 02-2448 for any additional fees  
required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly,  
extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By: Joe McKinney Muncy - re accepted  
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